

Inventor Information

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Application Information

Title Line One:: METHOD AND APPARATUS FOR ION
Title Line Two:: ATTACHMENT MASS SPECTROMETRY
Total Drawing Sheets:: 10
Docket Number:: 109675

Prior Foreign Applications

Foreign Application One:: 2000-169644
Filing Date:: June 6, 2000
Country:: JAPAN
Priority Claimed:: YES

Assignee Information

Name of assignee:: ANELVA CORPORATION
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